



2829

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Han et al.

Attorney Docket No.: KLA1P058/P880

Application No.: 10/058,614

Examiner: Nguyen, Vinh P.

Filed: January 28, 2002

Group: 2829

Title: ELECTRON BEAM INSPECTION SYSTEM
USING MULTIPLE ELECTRON BEAMS AND UNIFORM
FOCUS AND DEFLECTION MECHANISMS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on January 21, 2004 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

Mia M. Hines

AMENDMENT TRANSMITTAL

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims		MINUS			x 9 =	x 18 =
Independent Claims		MINUS			x 43 =	x 86 =
Multiple Dependent Claim Present and Fee Not Previously Paid					\$145.00	\$290.00
Total					\$	\$

- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- ☐ Enclosed is our Check No. _____ in the amount of \$ _____ to cover the additional claim fee and/or extension of time fees.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. KLA1P058).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP

Russell N. Swerdon
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P.O. Box 778
Berkeley, CA 94704-0778



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PATENT

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I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Arlington, VA 22313-1450 on January 21, 2004.

Signed: _____

Mia Mitchell-Haynes

Response to Office Action

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450

Sir:

Please consider the following amendments and remarks in response to the Office Action mailed on October 21, 2003. A listing of the claims commences on page 2 of this paper. No amendments to the claims are made in this paper. Remarks and arguments appear on page 5 of this paper.